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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **OKADA, Katsuhiko et al.**

Group Art Unit: 1714

Serial No.: 09/926,632

Examiner: Tae H. Yoon

Filed: November 27, 2001

P.T.O. Confirmation No.: 2956

For: **PRODUCTION METHOD FOR POWDER COATING, POWDER COATING AND
PAINT FILM FORMATION METHOD**

RESPONSE UNDER 37 CFR §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 1714

MAILSTOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 25, 2004

Sir:

In response to the Office Action dated **May 26, 2004**, please amend the above-identified application as follows: